

# BEAM TRIALS AT 1 MeV OF A DC ELECTRON ACCELERATOR

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## Abstract

A 3 MeV, 30 kW DC accelerator is under development at the Electron Beam Centre, Kharghar, Navi Mumbai for industrial applications and currently beam trials are on at 1 MeV, 5 kW. The paper gives a brief description of the beam-line and reports on the results of beam transmission experiments during these trials.

inside the pressure vessel. The coils are toroidally wound on iron half cylinders of 12 cm. internal diameter, 5 mm thickness and 20 cm height. The half-cylinders can be assembled around the beam-pipe to form a complete cylinder. X-Y fields can be generated by this arrangement to correct beam-straying by using a power supply able to provide current in the range of 0-5 A.

## INTRODUCTION

D.C. electron accelerators of energy ranging from a few hundred keVs to few MeVs and power from a few kilowatts to hundreds of kilowatts have industrial applications like medical sterilization, rubber vulcanization, polymerization & cross-linking, pollution control from thermal power stations etc. A 3 MeV, 30 kW DC accelerator is under development at Electron Beam Centre, Kharghar, Navi Mumbai by BARC to demonstrate such industrial applications. A schematic of the accelerator is shown in Fig. 1.

## ELECTRON GUN & ACCELERATING COLUMN

The electron gun uses a thermionically heated 10 mm diameter LaB<sub>6</sub> cathode which can be heated to about 1300<sup>0</sup> C by a Tungsten Filament fed by 100-150 watts of power. Cathode-anode voltage can be varied between 1-5 kV. The filament power supply and cathode-anode supply derive their power from the high voltage column.

The accelerating column consists of 10 accelerating tubes of National Electrostatics Corporation (NEC) make. Each tube is about 30 cm. long and can sustain a voltage of 335 kV with evacuation inside and outside in pressurized SF<sub>6</sub> environment. The accelerating tube consists of titanium electrodes with Alumina insulators separating consecutive electrodes with diffusion bonding between the ceramic and metal. The accelerating voltage derived from the accelerating column located in Nitrogen/SF<sub>6</sub> environment is divided by a resistor chain and the voltage applied to the electrodes. It is evacuated to 10<sup>-7</sup> millibar by Sputter Ion Pumps in the beam-line. It has an external pressure of 6 atmospheres.

## BEAM-LINE ELEMENTS

After the accelerating column, beam-pipe of 9.5 cm internal diameter is used for beam propagation. The beam-pipe consists of four separate sections, consecutive sections joined by conflate flanges.

A steering magnet is positioned 40 cm. away from the exit of the accelerating column in the first section and is

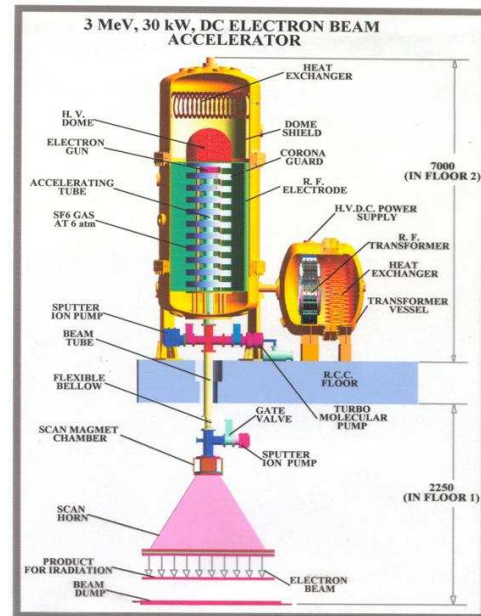


Figure 1: Schematic of DC Electron Accelerator.

The third section of the beam-pipe has access for a sputter ion pump of speed 500 litres/s. This section is joined to the next section by a bellow. In the fourth section of the beam-pipe, a focussing coil is wound over the beam-pipe along a length of 15 cm. It can provide a maximum of 5000 ampere turns to reduce beam size if required.

After about 3 meter distance from the end of accelerating column, the scanning section is located. In the scanning section, the cross-section is obround so that magnetic field can be provided in a region of 7.5 cm (Z) x 10 cm(X), the magnet gap being 5cm.(Y). Z direction refers to the initial beam direction, Y to the direction of the magnetic field and X to the direction of scanning. The wall thickness of the scan chamber is 1.25 mm to allow penetration of flux into beam-line to cause deflection. An H-shaped scanning magnet made of 0.23 mm thick silicon steel laminations is used to scan the

